



#71A
T. YOUNG
5-14-99

PATENT
ATTORNEY DOCKET NO. 07977/208001/US3511

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al. Art Unit: 2814
Serial No.: 08/994,038 Examiner: W. Coleman
Filed : 12/18/97
Title : CHARGE TRANSFER SEMICONDUCTOR DEVICE AND MANUFACTURING
METHOD THEREOF

Assistant Commissioner for Patents
Washington, DC 20231

AMENDMENT

Sir:

In response to the Official Action dated December 29,
1998, paper no. 5 in the above-referenced case, kindly amend the
above-referenced application as follows:

In the Claims

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MAY 13 1999

TECHNOLOGY CENTER 2800

Please add new claims 16-23.

16. (New) A semiconductor device comprising:
a crystalline semiconductor film being formed on an
insulating surface, said crystalline semiconductor film having a

Date of Deposit

4-29-99

I hereby certify under 37 CFR 1.8(a) that this correspondence is
being deposited with the United States Postal Service as first class
mail with sufficient postage on the date indicated above and is
addressed to the Assistant Commissioner for Patents, Washington,
D.C. 20231.

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02 FC:102
03 FC:103
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Janet Christy
[Signature]